

<b>Notice of References Cited</b>	Application/Control No. 10/623,843	Applicant(s)/Patent Under Reexamination POLEI ET AL.	
	Examiner Khiem D Nguyen	Art Unit 2823	Page 1 of 1

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*	C	US-6,518,103	02-2003	Lai, Jiun-Ren	438/150
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